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August 13, 2004

[062002-1751]

TO

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FROM

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RE: 09/855,972

(Message) Examiner Hassanzadeh, this is transmission 5 of 5.

Number of Pages (Including This Cover Sheet): - 26 - Page(s)
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PAGE 1/26 * RCVD AT 8/13/2004 12:35:19 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-3/24 * DNI:2731435 * CSID: * DURATION (mm:ss):11-56

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I hereby certify that this correspondence is being transmitted by facsimile to:

ATTN: Parvis Hassanzadeh
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Commissioner for Patents
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on August 13, 2004.

Eric Ringer
Eric Ringer

In re application of:	Kevin P. Martin et al.	Confirmation No.:	1603
U.S. Serial Number:	09/855,972	Art Unit:	1763
Filing Date:	May 15, 2001	Examiner:	Hassanzadeh, Parvis
Our Reference Number:	62002-1751		

Title: **Method and Apparatus for Low Energy Electron Enhanced Etching or
Substrates in an AC or DC Plasma Environment**

1 Cited References (Articles Only)